

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

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INFORMATION DISCLOSURE
STATEMENT

Docket Number
10191/3447

Application Number
To Be Assigned

Filing Date
Herewith

Examiner
To Be Assigned

Art Unit
To Be Assigned

Invention Title
MICROMECHANICAL COMPONENT
AND METHOD

Inventor(s)
LAMMEL et al.

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicants hereby bring the following references to the attention of the Examiner. The references are listed on the attached modified PTO form 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.
2. A copy of each patent, publication or other information listed on the modified PTO form 1449 is enclosed, except as otherwise indicated on the modified PTO form 1449.

Dated: 3/23/05

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INFORMATION DISCLOSURE STATEMENT BY APPLICANTS PTO FORM 1449	Atty. Docket No. 10191/3447	Serial No. 10/529420 To Be Assigned
	Applicant(s) LAMMEL et al.	
	Filing Date Herewith	Group To Be Assigned

U. S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NUMBER	PATENT DATE	NAME	CLASS	SUBCLASS	FILING DATE
	5,882,496*	Mar. 16, 1999	YU et al.			
	6,139,758*	Oct. 31, 2000	Xiangzheng TU			

* Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION	
						YES	NO
	96 39632*	Dec. 12, 1996	PCT				
	02 02458*	Jan. 10, 2002	PCT				

* Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

OTHER DOCUMENTS

EXAMINER'S INITIALS	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Henmi et al., <i>Vacuum Packaging for Microsensors by Glass-Silicon Anodic Bonding</i> , Sensors and Actuators, Lausanne, Switzerland, May 1, 1994, Vol. A43, No. 1/3, pgs. 243-48.*

* Copy of reference is not enclosed because reference is cited in Search Report (copy of reference provided by International Searching Authority).

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	